

Electronic Supplementary Information for

Gate-controlled photo-oxidation of graphene for electronic structure modification

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- Supporting figure S1: Spectrum of the ultraviolet light source used in this study

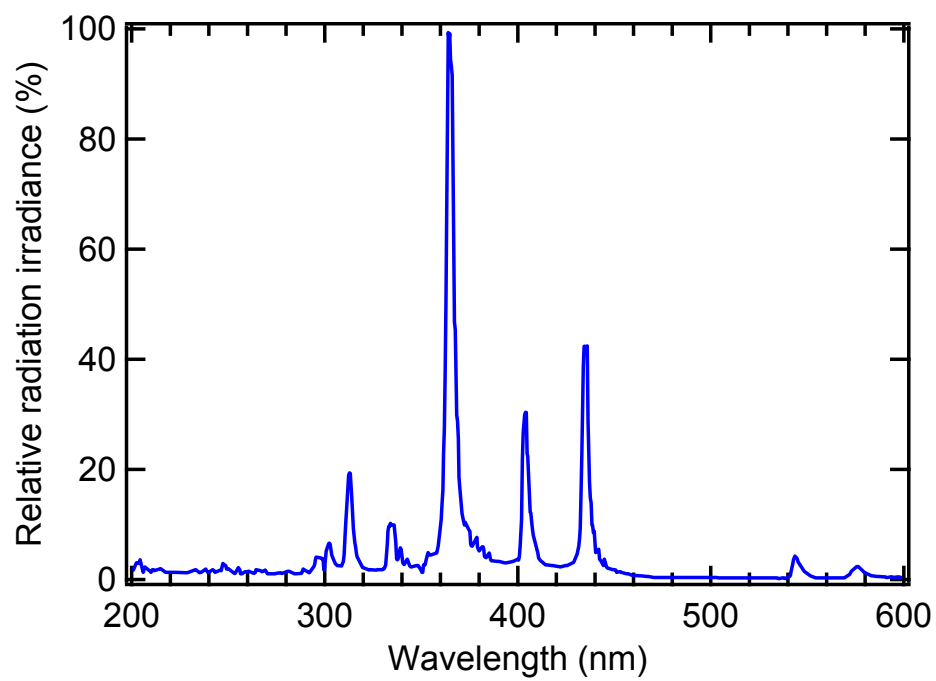


Fig. S1 Spectrum of the ultraviolet light source used in this study.